

## DirectView2 Camera

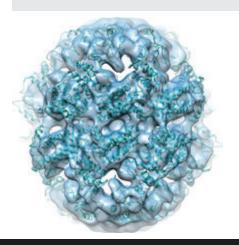
## versatile & economical direct detection

delivering | bigger | better | faster | cameras for electron microscopy

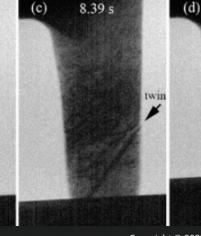
## Direct Detection for Transmission Electron Microscopy

- Direct detection device (DDD®) delivers ultra-high speed, extraordinary resolution, and ultra-low noise.
- $4k \times 4k$  (16.8 million) pixels.
- Ideal for a broad range of applications for both materials science (including in situ TEM, 4D-STEM, low-dose, etc.) and biological cryo-EM.
- Reach sub-nanometer resolution with cryo-EM on 120 kV LaB6 TEMs.
- High-speed continuous streaming for in situ TEM movies and motion-corrected imaging.
- Integrated Faraday plate.
- Based on our DE-Series platform which has a long track record of proven performance.
- Low total cost-of-ownership and exceptional support.
- The most impactful and cost-effective upgrade to a TEM's capabilities.

Cryo-EM of Mm-Cpn on a 120 kV LaB6 TEM, yielding ~10 Å resolution with about 1-hour data collection.



Frame from an in situ TEM movie at 57 fps. Courtesy of Zhiwei Shan (Xi'an Jiaotong University, China).



Applications



Microscopy

Direct Electron





## DirectView2 Camera

email | info@directelectron.com | web | www.directelectron.com | phone | +1 858-384-0291

TEM electron energy sensitive to 80 keV – 200 keV | optimized for 120 - 200 keV

pixel array specification 4096 × 4096 (16.8 million pixels) | 6.5 µm pixel pitch

single electron SNR ~20:1 (200 kV)

computer system

image format

sensor design >3T pixel design with on-chip correlated double sampling (CDS)

backthinned | radiation hardened

acquisition frame rate 42 fps max, unbinned full-frame

subarray readout up to 1000 fps (4096 × 128) | user-selectable hardware frame rate

acquisition modes integrating mode | counting mode (optional)

exposure rate large dynamic range with consistent performance (e.g., >250 e<sup>-</sup>/pixel/s)

mounting position fully retractable | mounted on-axis TEM bottom port or in JEOL film drawer

exposure measurement integrated Faraday plate for exposure measurement with each acquisition

sensor protection integrated sensor protection shutter | TEM blanking/shuttering | failsafe software

high-performance computer | Windows 10 | NVidia GPU(s) | up to 48 TB storage

non-proprietary to ensure broad compatibility | TIFF, MRC, HDF5, etc.

acquisition software DE-MissionControl (DE-MC)

compatibility SerialEM | Leginon | JADAS (JEOL) | Panta Rhei (CEOS)

customization open application programming interface (API) and software development kit (SDK)

with examples in C, C++, C#, and Python